

Instrumentation

DETECTORS, ANALYZERS, AND PURIFIERS



Equipamientos Analíticos S.A.

DESDE 1989 | BRINDANDO SOLUCIONES

Most of the components we supply to the instrumentation industry are from our valve and fitting lines. The rest, from our R&D 100 Award-winning pulsed discharge detectors to our application-dedicated trace gas analyzers, are primarily for gas detection and purification.

Pulsed discharge detectors

Non-radioactive, multiple mode electron capture / helium photoionization

VICI PDDs (pulsed discharge detectors) utilize a stable, low powered, pulsed DC discharge in helium as an ionization source. Eluants from the column, flowing counter to the flow of helium from the discharge zone, are ionized by photons from the helium discharge. The bias electrode(s) focus the resulting electrons toward the collector electrode, where they cause changes in the standing current which are quantified as the detector output. Performance is equal to or better than detectors with conventional radioactive sources.

In the electron capture mode, the PDD is a selective detector for monitoring high electron affinity compounds such as freons, chlorinated pesticides, and other halogen compounds. For this type of compound, the minimum detectable quantity (MDQ) is at the femtogram (10^{-15}) or picogram (10^{-12}) level.

In the helium photoionization mode, the PDD is a universal, non-destructive, high sensitivity detector. The response to both inorganic and organic compounds is linear over a wide range. Response to fixed gases is positive (increase in standing current), with an MDQ in the low ppb range.

The PDD in helium photoionization mode is an ideal replacement for FIDs in petrochemical or refinery environments, where the hydrogen and flame can be problematic. In addition, when the discharge gas is doped with argon, krypton, or xenon (depending on the desired cutoff point), the PDD functions as a specific photoionization detector for selective determination of aliphatics, aromatics, amines, and other species.



**R&D 100 AWARD
WINNER**

MORE INFORMATION

Pulsed discharge
detectors

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Plug-and-play detectors

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Model D-2

The D-2 is a dual mode, universal detector system which can be retro-fitted to your older GC. The D-2-I is optimized for trace level work in the helium photoionization mode. The stand-alone systems include detector, controller, electrometer, HP2 helium purifier (see page 226), and power supply.



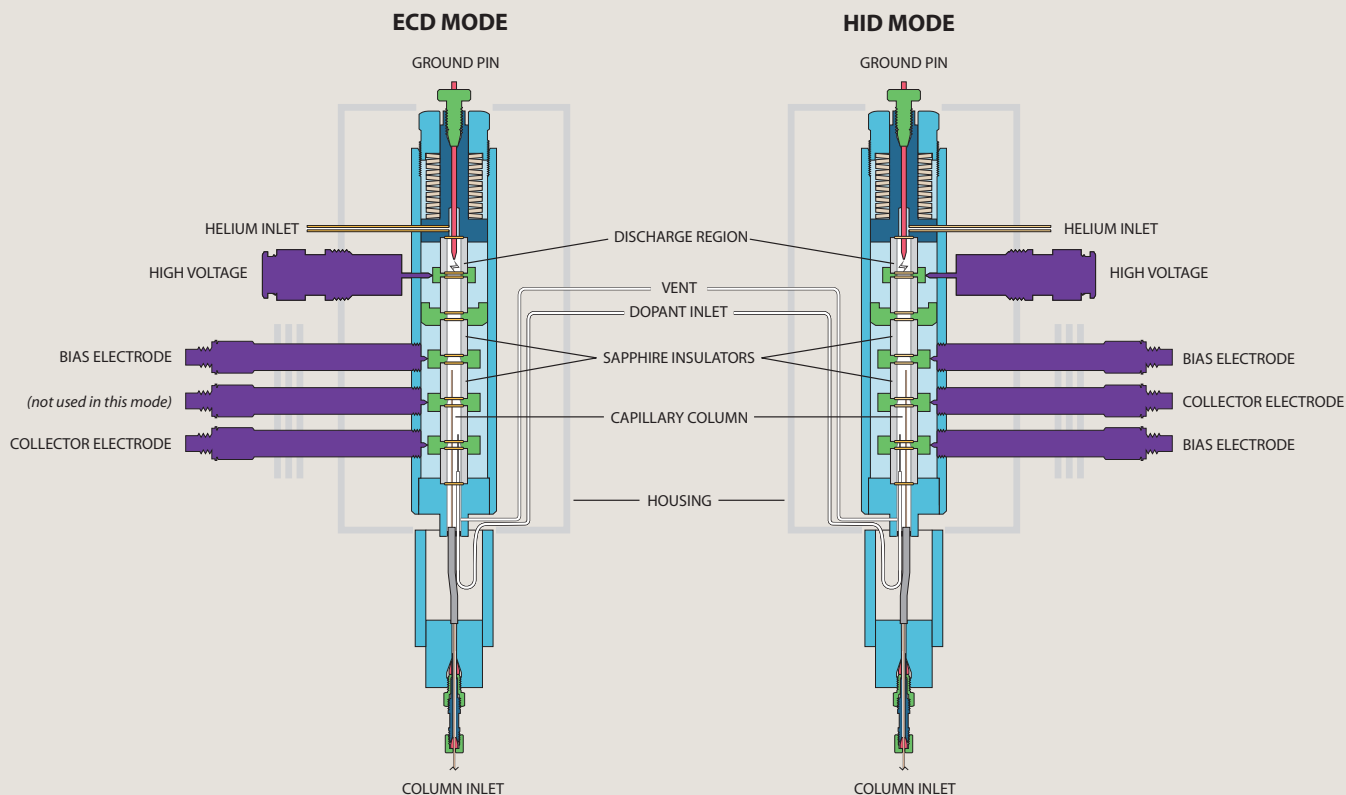
PDD Model D-2

Stand-alone system

Detector system includes detector cell, pulser, controller, electrometer, and helium purifier.

Description	110 VAC		230 VAC	
	Prod No	Price	Prod No	Price
Mode-selectable universal electron capture / photoionization detector system	D-2	\$5500	D-2-220	\$5500
Detectors optimized for trace level work in helium photoionization mode				
Optimized for packed column use	D-2-I	5200	D-2-I-220	5200

Model D-2

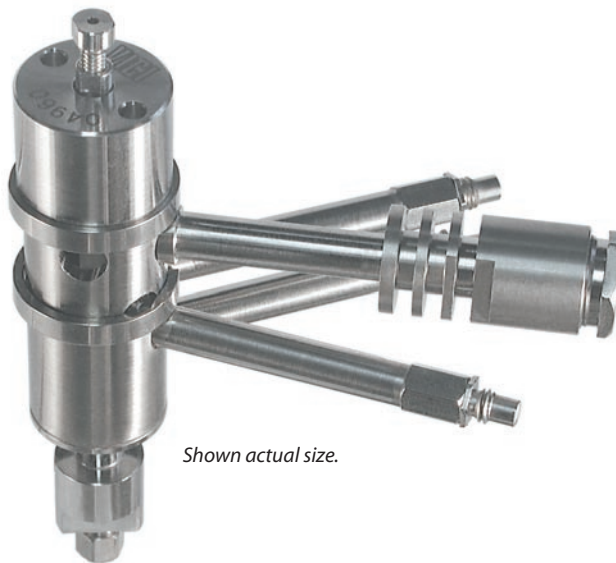


INSTRUMENTATION

miniPDD helium ionization detectors

The newest member of the PDD family is also the smallest and thriftiest. The miniPDD uses about one fifth (20%) the amount of helium as the D-3 and D-4 versions, giving up only a bit of sensitivity and dynamic range in return. It is approximately one half the size of the D-4, but has nearly the same sensitivity – about 100 ppb for fixed gases. With its reduced size, weight, and helium consumption, it is particularly well suited to portable applications, or to any situation in which the high cost of helium becomes a consideration.

It can be paired with other Valco components (controller, pulse module, helium purifiers, etc.) or can be purchased alone for use with existing components. Call today to discuss the endless possibilities.

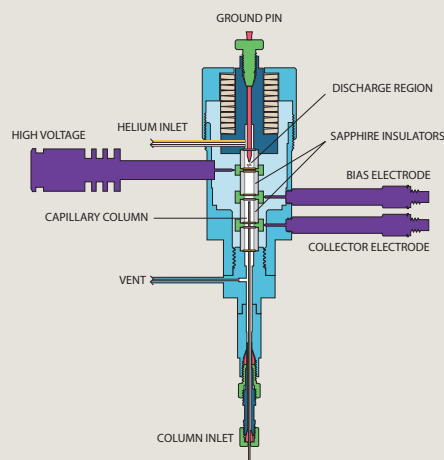
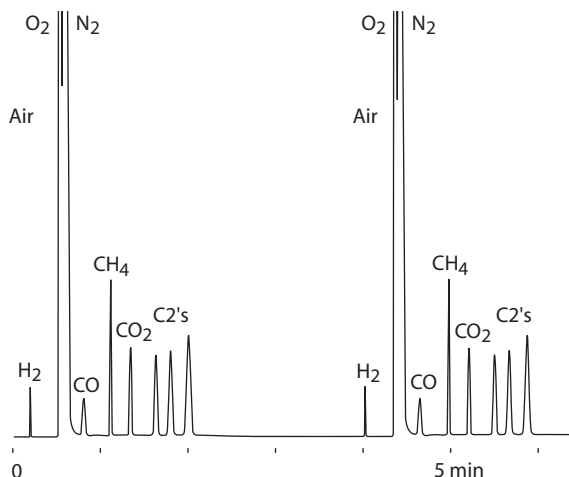


Shown actual size.

NEW PDD Model D2-IM *Helium photoionization*

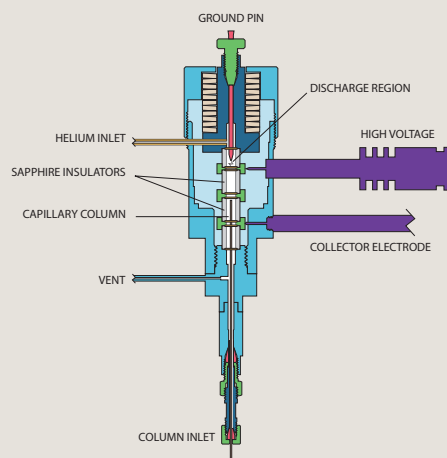
Detector cell only optimized for helium photoionization mode

Description	Prod No	Price
miniPDD cell only	PD-D2-IM	\$3200

Model D-2-IM schematic**miniPDD Model D-2-IM****TWO CONSECUTIVE RUNS OF LIGHT HYDROCARBONS IN AIR**

Detector: miniPDD Model PD-2-IM
 Detector temp: 150°C
 Column: 100/120 ShinCarbon
 1.4 m x 0.53 mm Silcosteel
 Resistive heat: 30°C (0.9 min) to 230°C
 at 100°C/min (hold 1 min)
 Sample: 2000 ppm in air, 2 µL size
 Carrier: Helium
 Discharge gas: Helium

Model D-3 schematic



Plug-and-play detectors for Agilent 7890 and 6890

Model D-3 is designed for plug-and-play installation on the popular Agilent 6890 and 7890, and is optimized for trace level work in the helium photoionization mode.

Both versions utilize the electronics and power supply of the host GC.

PDD Model D-3

Helium photoionization

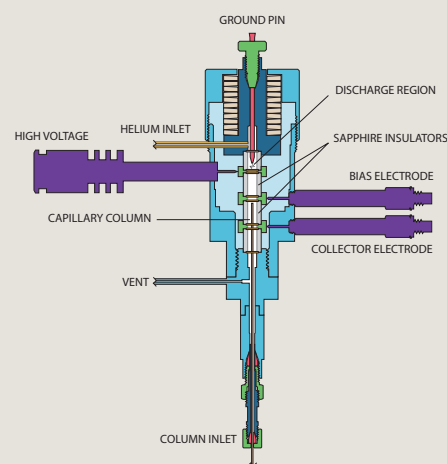
Detector optimized for trace level work in helium photoionization mode

Description	110 VAC		230 VAC	
	Prod No	Price	Prod No	Price
Plug-in system for Agilent 7890	D-3-I-7890	\$5800	D-3-I-7890-220	\$5800
Plug-in system for Agilent 6890	D-3-I-HP	6210	D-3-I-HP-220	6210



**D-3-I-HP plug-in system
for Agilent 6890 GC**

Model D-4 schematic



Plug-and-play detectors for other GCs

Pulsed Discharge Detector Model D-4 is available in versions for easy installation on most of the GCs in current use, including the Varian 3800; Shimadzu 14, 17, 2010, and 2014;

ThermoFinnigan Trace, Mega, and Top; and Hewlett Packard 5890. The D-4 is single mode, optimized for trace level work in the helium photoionization mode.

PDD Model D-4

Helium photoionization

Detectors optimized for trace level work in helium photoionization mode

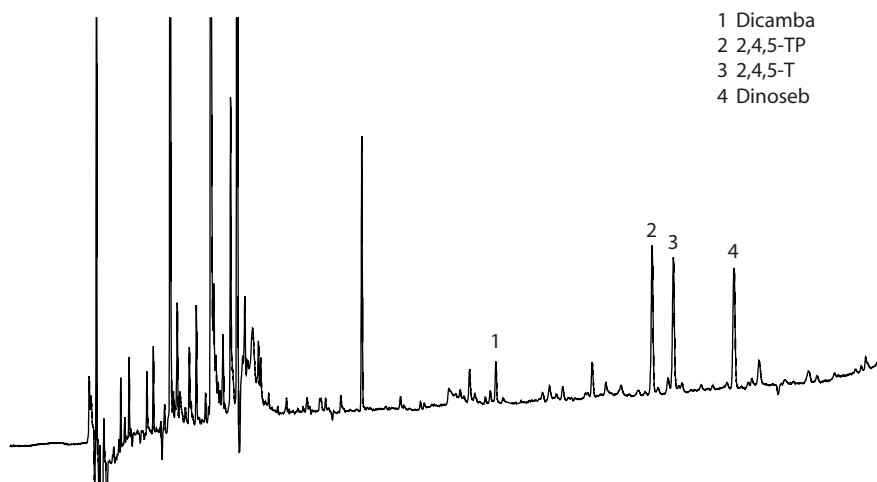
Description	110 VAC		230 VAC	
	Prod No	Price	Prod No	Price
Specialized detector for				
HP 5890	D-4-I-HP58	\$5200	D-4-I-HP58-220	\$5200
Shimadzu GC 14 *	D-4-I-SH14-R	3900	D-4-I-SH14-R-220	3900
Shimadzu GC 17, 2010, 2014 *	D-4-I-SH17-R	3900	D-4-I-SH17-R-220	3900
Thermo Trace GC *	D-4-I-TQ-R	3900	D-4-I-TQ-R-220	3900
Varian 3800 *	D-4-I-VA38-R	3900	D-4-I-VA38-R-220	3900
* Uses existing GC FID electrometer.				
For all other GCs	D-4-I	5100	D-4-I-220	5100

INSTRUMENTATION

Model D-2

**HERBICIDES IN SOIL SAMPLES
USING EPA METHOD 8151**

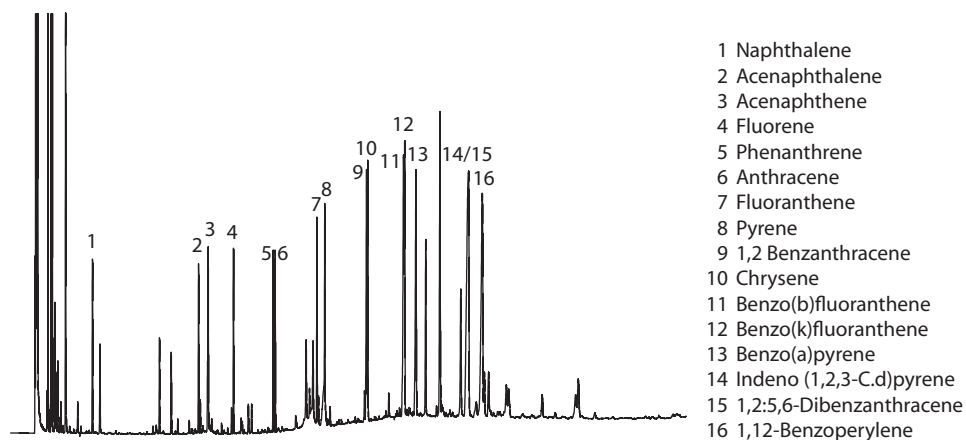
Detector: PDD Model D-2
 Mode: Electron capture
 Sample: Environmental soil (1 g)
 Detector temp: 320°C
 Column: ValcoBond VB-5
 30 m x 0.25 mm x 0.25 µm
 Column temp: 60°C (2 min),
 20°C/min to 180°C,
 4°C/min to 220°C,
 40°C/min to 300°C (5 min)
 Injector temp: 200°C
 Sample volume: 2 µL (solvent microextrac-
 tion), 1:15 split
 Discharge gas: Helium
 Dopant gas: Helium/argon
 Attenuation: 1



PDD Model D-2

**PAH RESIDUES IN AN
ENVIRONMENTAL SOIL SAMPLE SPIKE**

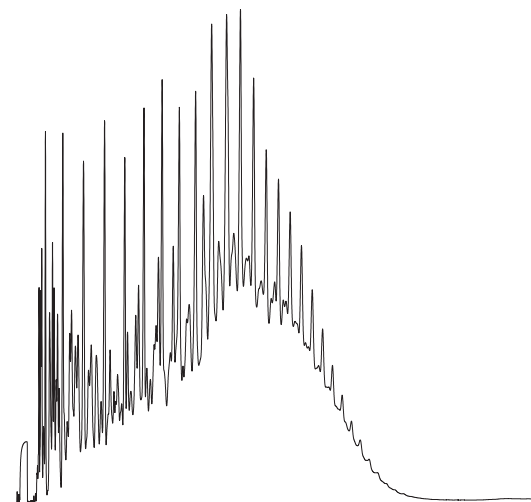
Detector: PDD Model D-2
 Mode: Helium photoionization
 Sample: Environmental soil (1 g)
 Detector temp: 300°C
 Column: ValcoBond VB-35
 30 m x 0.25 mm x 0.25 µm
 Column temp: 120°C for 3 min, 15°C/min
 to 310°C for 15 min
 Injector temp: 275°C
 Sample volume: 2 µL (solvent microextrac-
 tion), 1:15 split
 Discharge gas: Helium
 Dopant gas: none
 Attenuation: 1



miniPDD Model D-2-IM

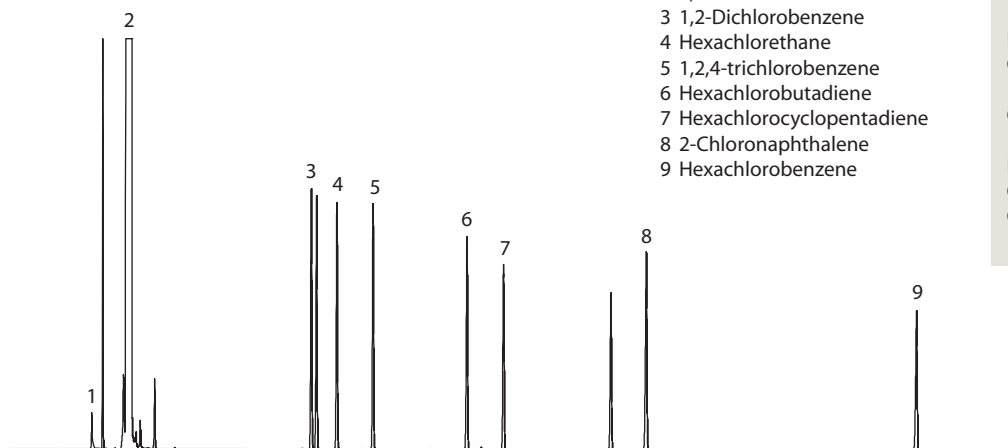
**SIMULATED DISTILLATION
IN TWO MINUTES**

Detector: miniPDD
 Detector temp: 320°C
 Column: ValcoBond® VB-1
 5 m x 0.25 mm x 0.20 µm
 Column temp: 40°C initial for 0.1 min
 to 320°C at 150°C/min
 Injector temp: Cold on-column injection
 Carrier gas: Helium
 Reference gas: Helium
 Sample: Reference Gas Oil (RGO)
 provided by
 Separation Systems, Inc.



PDD Model D-3

- 1 1,3-Dichlorobenzene
- 2 1,4-Dichlorobenzene
- 3 1,2-Dichlorobenzene
- 4 Hexachlorethane
- 5 1,2,4-trichlorobenzene
- 6 Hexachlorobutadiene
- 7 Hexachlorocyclopentadiene
- 8 2-Chloronaphthalene
- 9 Hexachlorobenzene

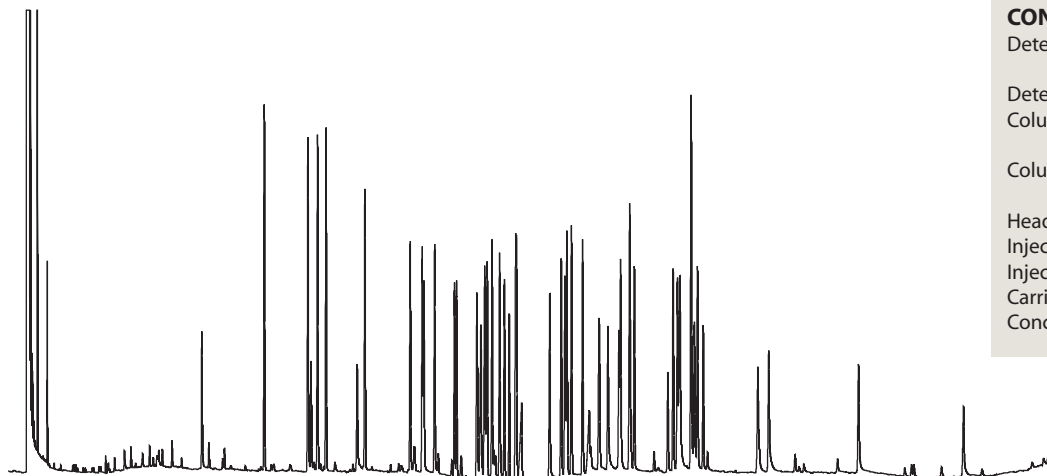
**CHLORINATED HYDROCARBONS**

Detector: PDD Model D-3
Helium photoionization
Detector temp: 280°C
Column: ValcoBond VB-5
30 m x 0.25 mm x .25 µm
Column temp: 60°C initial to
320°C at 10°C/min
Injector temp: 280°C
Carrier gas: Helium
Concentration: 5 mg/ml

PDD Model D-3

NITROGEN- AND PHOSPHOROUS-CONTAINING PESTICIDES

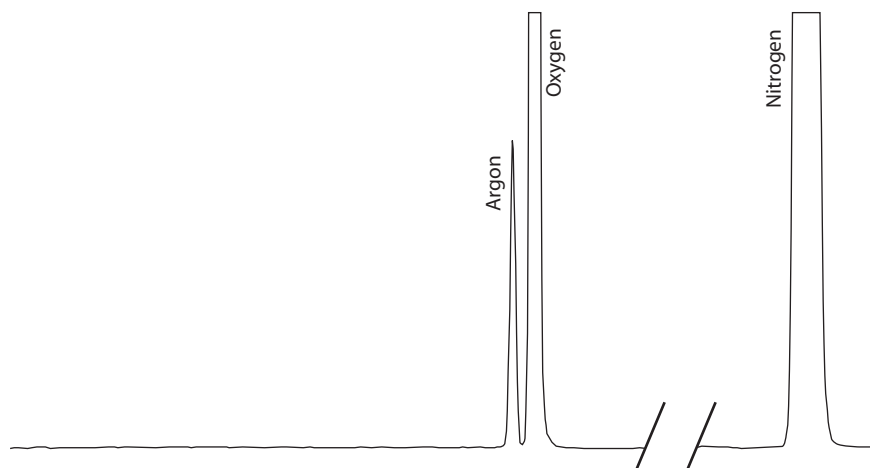
Detector: PDD Model D-3
Helium photoionization
Detector temp: 280°C
Column: ValcoBond VB-5
30 m x 0.25 mm x .25 µm
Column temp: 60°C initial to
320°C at 10°C/min
Head pressure: 15 psi
Injector temp: 280°C
Injector: Split 1:10
Carrier gas: Helium
Concentration: 2.5 mg/ml



PDD Model D-3

AIR

Detector: PDD Model D-3
Helium photoionization
Detector temp: 300°C
Column: ValcoPLOT VP-Molesieve
30 m x 0.53 mm x 0.50 µm
Column temp: Ambient
Injector temp: 250°C
Discharge gas: Helium
Carrier gas: Helium



Helium and nitrogen purifiers

Carrier gas purity is essential in any application requiring extreme sensitivity. Impurities limit detector sensitivity and can even destroy capillary columns. The Valco HP2 provides "point-of-use" purification of helium or other noble gases, such as Ar, Ne, Kr, and Xe, to sub-ppm levels of reactive gaseous impurities. The NP2 is similar, purifying nitrogen to sub-ppm levels of gaseous impurities.

The purification substrate in Valco gas purifiers is a non-evaporable gettering alloy. This stable alloy is contained in a welded assembly, so the purifiers can be used safely in industrial applications with minimal precautions. The getter is activated by heating, which eliminates the oxide film on the particle surface and allows helium to diffuse into the bulk of the getter particles. The HP2 and NP2 feature a self-regulating design which eliminates the possibility of thermal runaway and maintains the getter material at the optimum temperature.



Standard helium and nitrogen purifiers

Includes universal power supply.

Description	Helium purifier		Nitrogen purifier	
	Prod No	Price	Prod No	Price
110 VAC	HP2	\$915	NP2	\$915
230 VAC	HP2-220	915	NP2-220	915

Replacement getter assembly

Helium	I-23572HP2	460
Nitrogen	I-23572NP2	460

HELIUM PURIFIER

- CE certified
- Gases purified He, Ne, Ar, Kr, Xe, Rn
- Maximum operating pressure 1000 psig
- Impurities removed Outlet impurities less than 10ppb H₂O, H₂, O₂, N₂, NO, NH₃, CO, CO₂, and CH₄, based on 10ppm total inlet impurities. Other impurities removed include CF₄, CCl₄, SiH₄ and light hydrocarbons.
- Impurities **not** removed He, Ne, Ar, Kr, Xe, Rn

NITROGEN PURIFIER

- CE certified
- Gases purified N₂ only
- Impurities removed Outlet impurities less than 10ppb H₂O, H₂, O₂, NO, NH₃, CO, CO₂, and CH₄, based on 10ppm total inlet impurities. Other impurities removed include CF₄, CCl₄, SiH₄ and light hydrocarbons.
- Impurities **not** removed He, Ne, Ar, Kr, Xe, Rn, N₂



Miniature gas purifiers

The Valco Miniature Helium Purifier (HPM) and Miniature Nitrogen Purifier (NPM) are designed to be installed in a gas chromatograph's flow path immediately upstream of the injector.

The HPM/NPM will remove any contaminants introduced by flow controllers, elastomeric tube seals, pressure regulators, crude traps, or other system components that are not completely clean and leak-tight.

Mini helium and nitrogen purifiers

Includes universal power supply.

Description	Helium purifier		Nitrogen purifier	
	Prod No	Price	Prod No	Price
110 VAC	HPM	\$550	NPM	\$550
230 VAC	HPM-220	550	NPM-220	550



Microvolume thermal conductivity detector

Our dual filament TCD is a stand-alone unit consisting of the detector housing and a controller with electrometer and temperature controls. The detector cell includes two separate nickel/iron filaments, capable of independent or referenced (differential) operation. Cell volume and geometry are optimized for capillary chromatography and enhanced sensitivity at low flow

rates. (Recommended total flow rate: 2-10 mL/min.) Thermal stability is maintained to $\pm 0.02^{\circ}\text{C}$, resulting in a stable, noise-free signal. A single 0-1 millivolt attenuated output for a strip chart recorder is provided through the signal cable at the rear of the controller, with 0-1 volt and 0-10 volt unattenuated signals available through the remote signal cable.

TCD Thermal conductivity detectors

Description	110 VAC		230 VAC	
	Prod No	Price	Prod No	Price
Entire unit (cell and electronics)	TCD2-NIFE	\$3480	TCD2-NIFE-220	\$3480
Cell/oven assembly only, dual filament	TCD2-NIFED	1160	TCD2-NIFED-220	1160
TCD controller only	TCD2-C	2250	TCD2-C-220	2250